IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Liu, et al.

Serial No. Unknown

Serial No. Unknown

Serial Herewith

For: METHOD FOR FORMING DIELECTRIC
BARRIER LAYER IN DAMASCENE
STRUCTURE

SARtiorney Docket No.: 24061.142

Substituting The Serial No. 27683

Customer No. 27683

Group Art Unit: Unknown

Examiner: Unknown

Structure

Commissioner for Patents Washington, D.C. 20231

POWER OF ATTORNEY FOR PATENT APPLICATION

As a representative of the Assignee, Taiwan Semiconductor Manufacturing Company, Ltd., I hereby appoint the following attorneys and/or agents to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

David L. McCombs (Reg. No. 32,271); Jeffrey M. Becker (Reg. No. 35,442); James R. Bell (Reg. No. 26,528); Timothy F. Bliss (Reg. No. 50,925); Randall C. Brown (Reg. No. 31,213); Randall E. Colson (Reg. No. 40,566); Michael A. Davis, Jr. (Reg. No. 35,488); Andrew S. Ehmke (Reg. No. 50,271); Priscilla Ferguson (Reg. No. 42,531); Sarah T. Harris (Reg. No. 35,891); William E. Hickman (Reg. No. 46,771); Rita M. Irani (Reg. No. 31,028); Warren B. Kice (Reg. No. 22,732); J. Andrew Lowes (Reg. No. 40,706); Todd Mattingly (Reg. No. 40,298); John Montgomery (Reg. No. 31,124); Julie Nickols (Reg. No. 50,826); Gloria Norberg (Reg. No. 36,706); David M. O'Dell (Reg. No. 42,044); Richard V. Wells (Reg. No. 53,757).and Chien Wei Chou (Reg. No. 41,672).

Please address all correspondence and telephone calls regarding this application to:

David M. O'Dell Attorney for Applicants Haynes and Boone, LLP 901 Main Street, Suite 3100 Dallas, TX 75202-3789 972-739-8635

The undersigned is the representative for the Assignee of the entire right, title, and interest in the patent application identified above. A copy of the assignment or other documents in the chain of title are attached.

The undersigned (whose title is supplied below) is authorized to act on behalf of the Assignee.

	Taiwan Semiconductor Manufacturing, Inc.	
Date	Chien-Wei Chou Title: Director, IP Division	

PATENT / DOCKET NO.: 24061.142 CUSTOMER NO.: 27683

INVENTOR'S DECLARATION FOR PATENT APPLICATION

As below named inventors, we hereby declare that:

the enecification of which: (check one)

Our residence, post office address and citizenship are as stated below next to our names;

We believe we are the original, first and sole joint inventors of the subject matter which is claimed and for which a patent is sought on the invention entitled

METHOD FOR FORMING DIELECTRIC BARRIER LAYER IN DAMASCENE STRUCTURE

me specification	i of which. (check one)		
<u>X</u>	is attached hereto.		
	was filed onunder Attorney's Docket Numb as Application Serial Noand was amended on	er	(if applicable).
	e that we have reviewed and und aims, as amended by any amend		nts of the above identified specification, above.
in accordance which became a	•	continuation-in-pa of the prior applie	ial to the patentability of this application art applications, material information cation and the national or PCT
made on inform the knowledge t both, under 18	nation and belief are believed to that willful false statements and	be true; and furthe the like so made a	owledge are true and that all statements er that these statements were made with are punishable by fine or imprisonment, or may jeopardize the validity of the
We hereby clair application(s) li		ited States Code,	§ 119(e) of any United States provisional
(Application Nu	ımber)	(Filing Date)	

We hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or (f), or 365(b) of any foreign applications for patent, inventor's or plant breeder's rights certificate(s), or 365(a) of any PCT international application which designated at least one country other than the United States of America, listed below,

PATENT / DOCKET NO.: 24061.142 CUSTOMER NO.: 27683

any foreign application for patent, inventor's or plant breeder's rights certificate(s), or any PCT international application having a filing date before that of the application on which priority is claimed.

Prior Foreign	Country	Foreign Filing Date (MM/DD/YYYY)	Priority Claimed			
Application Number(s)						
			1			
FULL NAME OF INVENTOR: Ai-Sen Liu						
INVENTOR'S SIGNATURE: DATED:						
RESIDENCE:						
CITIZENSHIP:						
POST OFFICE ADDRESS:						
FULL NAME OF INVE		ng				
INVENTOR'S SIGNATURE: DATED:						
RESIDENCE:						
CITIZENSHIP:						
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